UF3000EX Prober		
Config for 8' or 12" wafers8 &12	Yes	
Chuck type (Gold or Nickel)	Nickel	
3S"20GB hard disk	Yes	
Ma1meto-optical drive	No	
Single FQUP port for 25 wafers	Yes	
Manual wafer inspection transfer unit	Yes	
Dual robotic wafer transfer arms	Yes	
Pre-ali1mment stage unit	Yes	
Auto needle alignment	Yes	
Advanced wafer alignment unit	Yes	
Alignment camera El-500	El-800	
Dual (X&Y) heidenhain scales	Xaxis	
Quad-pod Z stage	300KG	
Color LCD control panel with touch panel switches	Yes	
alarm lamp note	Yes	
Option		
Hot or cold chucks available(TSK or ERS)	1SK	hot &cold(-45~150)
Wafer ID options available (TSK ot Cognex)	ESI	
Needle cleaninfoption (Wafer type driven clisc type,staf e,brush)	Slal?:etype	
1Multi-site parallel probing option(3 to 256pins)	Yes	
GPIB interface option	Yes	